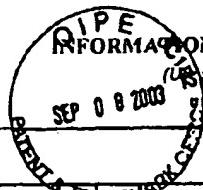


FORM PTO-1449 (REV.7-80)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. S00803.02	APPLICATION NO. 10/075,640
DRAFT INFORMATION DISCLOSURE STATEMENT <small>(Use several sheets if necessary)</small>		APPLICANT(S) Michael Nuttall and Garry Anthony Mercaldi	
		FILING DATE February 13, 2002	GROUP ART UNIT 2818



U.S. PATENT DOCUMENTS

*EXAMINER	DOC NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DV	AA 5,096,740	03/17/92	Nakagama et al.	427	53.1	—
DV	AB 6,172,454 B1	01/09/01	Hofmann	313	495	—
	AC					
	AD					
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FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AK							
	AL							
	AM							

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

DV	AN	Boman, M. et al., "Helical Microstructures Grown by Laser Assisted Chemical Vapour Deposition", Micro Electro Mechanical Systems, February 4-7, 1992, pp. 162-167.
DV	AO	Wallenberger, F.T., "Rapid Prototyping Directly from the Vapor Phase (Laser-assisted Chemical Vapor Deposition)", American Association for the Advancement of Science, March 3, 1995, pp. 1-5.
DV	AP	Westberg, H. et al., "Truly Three Dimensional Structures Microfabricated by Laser Chemical Processing", IEEE, 1991, pp. 516-519.

EXAMINER	DATE CONSIDERED
Struland	4/28/03

* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).

INFORMATION DISCLOSURE STATEMENT

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APPLICANT(S)

Michael Nuttall and Garry Anthony Mercaldi

FILING DATE

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2818

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DV	AA	5,776,621	07/07/98	Nashimoto	428	688	—
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FOREIGN PATENT DOCUMENTS

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FORM PTO-1449 (REV.7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 500803.02	APPLICATION NO. 10/075,640
INFORMATION DISCLOSURE STATEMENT <i>(Use several sheets if necessary)</i>		APPLICANT(S) Michael Nuttal and Garry Anthony Mercaldi			
		FILING DATE February 13, 2002	GROUP ART UNIT 2818		

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DV	AA	5,776,621	07/07/98	Nashimoto	428	688	—
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FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
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OTHER PRIOR ART *(Including Author, Title, Date, Pertinent Pages, Etc.)*

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		07/10/03

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FORM PTO-1449
(REV.7-80)

JUN 18 2002 U.S. DEPARTMENT OF COMMERCE

PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.
500803.02APPLICATION NO.
10/075,640

INFORMATION DISCLOSURE STATEMENT

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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DV	AA	4,686,758	08/18/87	Liu et al.	437	34	—
	AB	4,952,526	08/28/90	Pribat et al.	437	89	—
	AC	5,038,183	08/06/91	Kishi et al.	357	13	—
	AD	5,276,343	01/04/94	Kumagai et al.	257	306	—
	AE	5,422,299	06/06/95	Neudeck et al.	437	63	—
DV	AF	5,425,808	06/20/95	Tokunaga et al.	117	95	—
	AG						
	AH						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AI							
	AJ							

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

DV	AK	Philips Research Laboratories, N.V. Philips Gloeilampenfabrieken, Eindhoven, "Selective Epitaxial Deposition of Silicon", Nature No. 4840, August 4, 1962, pp. 485-486.
	AL	Rai-Choudhury P. et al., "Selective Growth of Epitaxial Silicon and Gallium Arsenide", Westinghouse Research Laboratories, Pittsburgh, Pennsylvania, January 1971, pp. 107-110.
	AM	Siekkinen J. W. et al., "SEG/ELO Material Characterization Using Silicon Bipolar Transistors", IEEE Bipolar Circuits & Technology Meeting, September 12-13, 1988, pp. 237-240.
DV	AN	Siekkinen J.W. et al., "Selective Epitaxial Growth Silicon Bipolar Transistors for Material Characterization", IEEE Transactions on Electron Devices, Vol. 35, No. 10, October 1988, pp. 1640-1644.

EXAMINER	DATE CONSIDERED
shuland	6/22/03

* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).